JUN 1 3 2008

1792

Applicant(s): Anatoly L. Vikharev et al.				ıtity)		Docket No.		
Application No.	Filing Date	Examiner		Customer N	ю.	Group Art Uni	t Confirmation No.	
10/526,800	March 7, 2005	Kelly M. Stouffe	:r	21036		1792	7409	
Invention: HIGH VELOCITY METHOD FOR DEPOSITING DIAMOND FILMS FROM A GASEOUS PHASE IN SHF DISCHARGE PLASMA AND DEVICE FOR CARRYING OUT SAID METHOD								
COMMISSIONERFOR PATENTS:								
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.								
		CLAIMS AS AM	IENDE)				
	CLAIMS REMAINING	HIGHEST#	NUMB	EREXTRA		RATE	ADDITIONAL	
	AFTER AMENDMENT	PREV. PAID FOR	CLAIMS	PRESENT			FEE	
TOTAL CLAIMS	12 -	22 =	ļ		X	\$50.00	\$0.00	
INDEP. CLAIMS	1 -	3 =	· .	0	X	\$210.00	\$0.00	
Multiple Depender	nt Claims (check if appl						\$0.00	
	•	TOTAL ADDITIONAL F	FEE FO	R THIS AME	NC)MENT	\$0.00	
□ Please charge Deposit Account No. in the amount of □ A check in the amount of to cover the filing fee is enclosed. □ The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 13-0610 □ Any additional filing fees required under 37 C.F.R. 1.16. □ Any patent application processing fees under 37 C.F.R. 1.17. □ Payment by credit card. Form PTO-2038. WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038. □ Dated: June 11, 2008 □ June								
cc:		Signature of Person Mailing Correspondence Tammi L. Taylor						
				Typed or Printed Name of Person Mailing Correspondence				



IOAP 4.1-1

Appl. No. 10/526,800

Amdt. Dated: June 9, 2008

Reply to Office Action/Restriction Requirement mailed May 13, 2008

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appln. No. : 10/526,800 Confirmation No. 7409

Applicants : Anatoly L. Vikharev et al.

Filed : March 7, 2005

Title : HIGH VELOCITY METHOD FOR DEPOSITING

DIAMOND FILMS FROM A GASEOUS PHASE IN SHF DISCHARGE PLASMA AND DEVICE FOR

CARRYING OUT SAID METHOD

TC/A.U. : 1792

Examiner : Kelly M. Stouffer

Docket No. : IOAP 4.1-1

Customer No.: 21036

MAIL STOP AMENDMENT COMMISSIONER FOR PATENTS P. O. BOX 1450

ALEXANDRIA VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT UNDER 35 USC 121

Sir:

In response to the Restriction Requirement mailed May 13, 2008, Applicants elect Claims 7-15 in Group II. The election is without traverse.

IOAP 4.1-1

Appl. No. 10/526,800 Amdt. Dated: June 9, 2008

Reply to Office Action/Restriction Requirement mailed May 13, 2008

An Office Action on the merits is requested.

Respectfully,

Ian C. McLeod

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